S/N 09/825,613 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Sujit Sharan et al.

Examiner: Asok K Sarkar

Serial No.:

09/825,613

Group Art Unit: 2829

Filed:

April 3, 2001

Docket No.: 303.930US4

6T. 10.

METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

FEB 2 8 2006 °

AMENDMENT UNDER 37 CFR § 1.111

Mail Stop Petition

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

This paper responds to the Decision on Appeal from the Board of Patent Appeals and Interferences mailed on <u>December 30, 2005</u>. Please amend the above-identified patent application as follows.